

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?:: NONE
Title:: SILICON CARBIDE THERMOSTABLE
POROUS STRUCTURAL MATERIAL
AND PROCESS FOR PRODUCING THE
SAME
Attorney Docket Number:: 264179US0PCT

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
Given Name:: Elji
Family Name:: ✓ TANI
City of Residence:: Saga
Country of Residence:: Japan
Street of Mailing Address:: c/o Natl Inst. of Advanced Indust Science
and Tech. Kyushu, 807-1, Shuku-machi
Tosu-shi
City of Mailing Address:: Saga
Country of Mailing Address:: Japan
Postal or Zip Code of Mailing Address:: 841-0052

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP03/09434	07/25/03

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2002-218247	Japan	07/26/02	YES

ASSIGNMENT INFORMATION

Assignee Name::	National Institute of Advanced Indust Sci & Tech
Street of Mailing Address::	3-1, Kasumigaseki 1-chome, Chiyoda-ku
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Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	100-8921